



EFW

Docket No.: 060188-0594

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Shuji HIRAO	:	Confirmation Number: 6629
Application No.: 10/624,564	:	Group Art Unit: 1753
Filed: July 23, 2003	:	Examiner: WONG, Edna

For: METHOD AND APPARATUS FOR PLATING SUBSTRATE

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Restriction Requirement
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Noting the Office Action of March 24, 2006 wherein restriction has been required, Applicant hereby elects Group I (claims 1-11) for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

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Date: April 24, 2006